

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. TI-27203		SERIAL NO. 09/276,780 TBD	
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Hutter, et al.			
				FILING DATE 03/25/99		GROUP TBD	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
CAL	AR	A. R. Alvarez, ed., 3.1 Evolution of BiCMOS From a CMOS Perspective , Kluwer Acad. Publ. 1989, pages 65-68
CAL	AS	J. A. Bruchez, et al., The Philosophy of a Simple Collector Diffusion Isolation Bipolar Process , Solid State Technology/August 1987, pages 93-97
CAL	AT	Robert T. Havemann, et al., Process Integration Issues for Submicron BiCMOS Technology , Solid State Technology/June 1992, pages 71-76
	AU	

EXAMINER 	DATE CONSIDERED September 15, 2000
------------------	---

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.